

GP. 2508
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Docket No. 0756-958

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:)
Shunpei YAMAZAKI et al.) Examiner: S. Crane
Serial No. 08/183,800) Art Unit: 2508
Filed: January 21, 1994)
For: SEMICONDUCTOR MATERIAL)
AND METHOD FOR FORMING)
THE SAME AND THIN FILM)
TRANSISTOR) June 26, 1998

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on June 26, 1998.

Ingeborg S. Alexander
Ingeborg S. Alexander

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JUL 08 1998

GROUP 2100

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Transmitted herewith is an Amendment, Petition For Extension of Time, Information Disclosure Statement, Form PTO-1449, and Submission of Related Applications in the above-identified application.

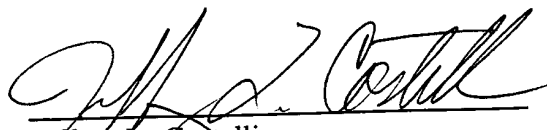
- [] Small entity status of this application under 37 C.F.R. 1.9 and 1.27 has been established by a verified statement previously submitted.
- [] A verified statement to establish small entity status under 37 C.F.R. 1.9 and 1.27 is enclosed.
- [] No additional claim fee is required.

[] An additional claim fee is required and is calculated as shown below:

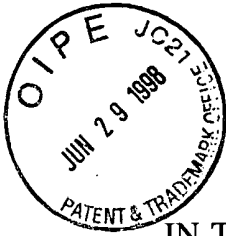
	Claims Remaining After Amendment		Highest Number Previously Paid For	Present Extra	Small/Large Entity Rate	Fee
Total	27	Minus	26	1	x \$11/\$22	\$22
Indep.	11	Minus	10	1	x \$41/\$82	\$82
First Presentation of Multiple Dependent Claim					+ \$135/\$270	
TOTAL						\$104

- [X] A check in the amount of \$744.00 to cover the additional claims fee, extension of time fee, and IDS fee is enclosed.
- [X] In the event applicant(s) has overlooked the need for any petition and fee for extension of time, and such extension is required, applicant(s) requests that this be considered a petition therefor and that such fee be charged to Deposit Account No. 19-2380 (0756-0958).
- [X] The Commissioner is hereby authorized to charge fees under 37 CFR 1.16 and 1.17 (except the Issue Fee) which may be required now or hereafter, or credit any overpayment, to Deposit Account No. 19-2380 (0756-0958). A duplicate copy of this sheet is attached.

Respectfully submitted,


 Jeffrey L. Costellia
 Registration No. 35,483

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 McLean, Virginia 22102
 (703) 790-9110
 (703) 883-0370 (Fax)



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SUBMISSION OF RELATED APPLICATIONS

GROUP 2100


Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Pursuant to Applicant's duty of candor under 37 C.F.R. §1.56, Applicant wishes to inform the Examiner of the following applications directed to related technical subject matter:

<u>Serial No.</u>	<u>Filing Date</u>	<u>Title</u>
08/095,172	07/23/93	Semiconductor Material And Method For Forming The Same And Thin Film Transistor
08/428,842	04/25/95	Insulated Gate Field Effect Semiconductor Device

Respectfully submitted,



Jeffrey L. Costellia
Reg. No. 35,483

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